

Depleted monolithic CMOS pixel detectors in 150 nm LFoundry technology for the ATLAS Inner Tracker Upgrade

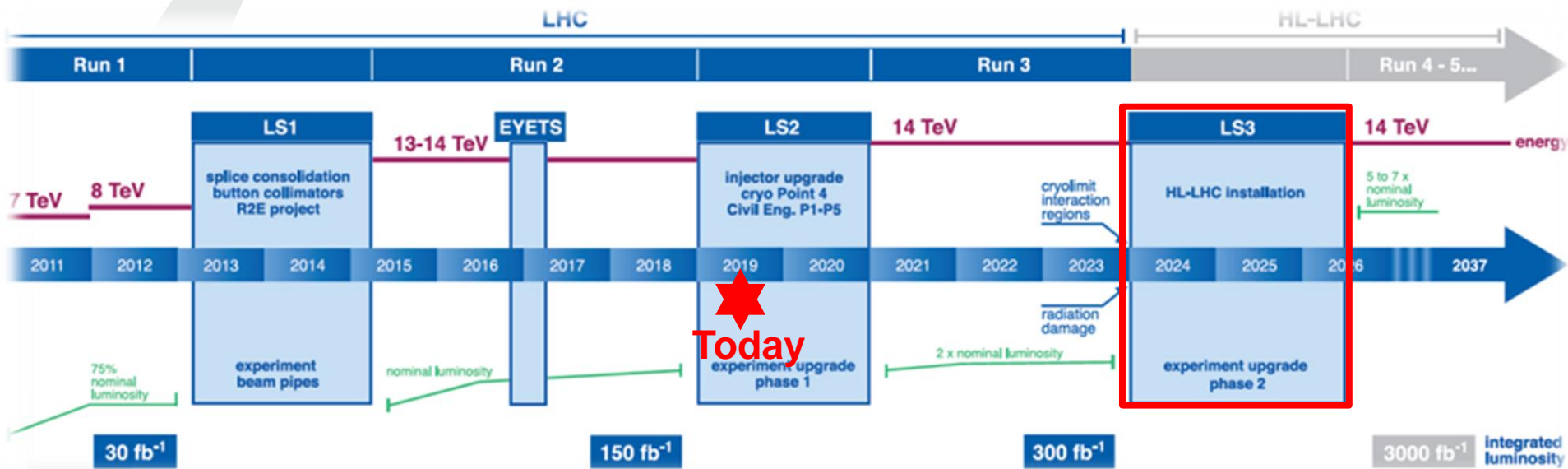
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STREAM Final Conference
Geneva, 17th Sep 2019



- ATLAS Inner Tracker (ITk) upgrade
- CMOS sensor option for pixels
- LF-CPIX characterization and beam measurement
- LF-Monopix1 characterization and beam measurement
- Conclusion

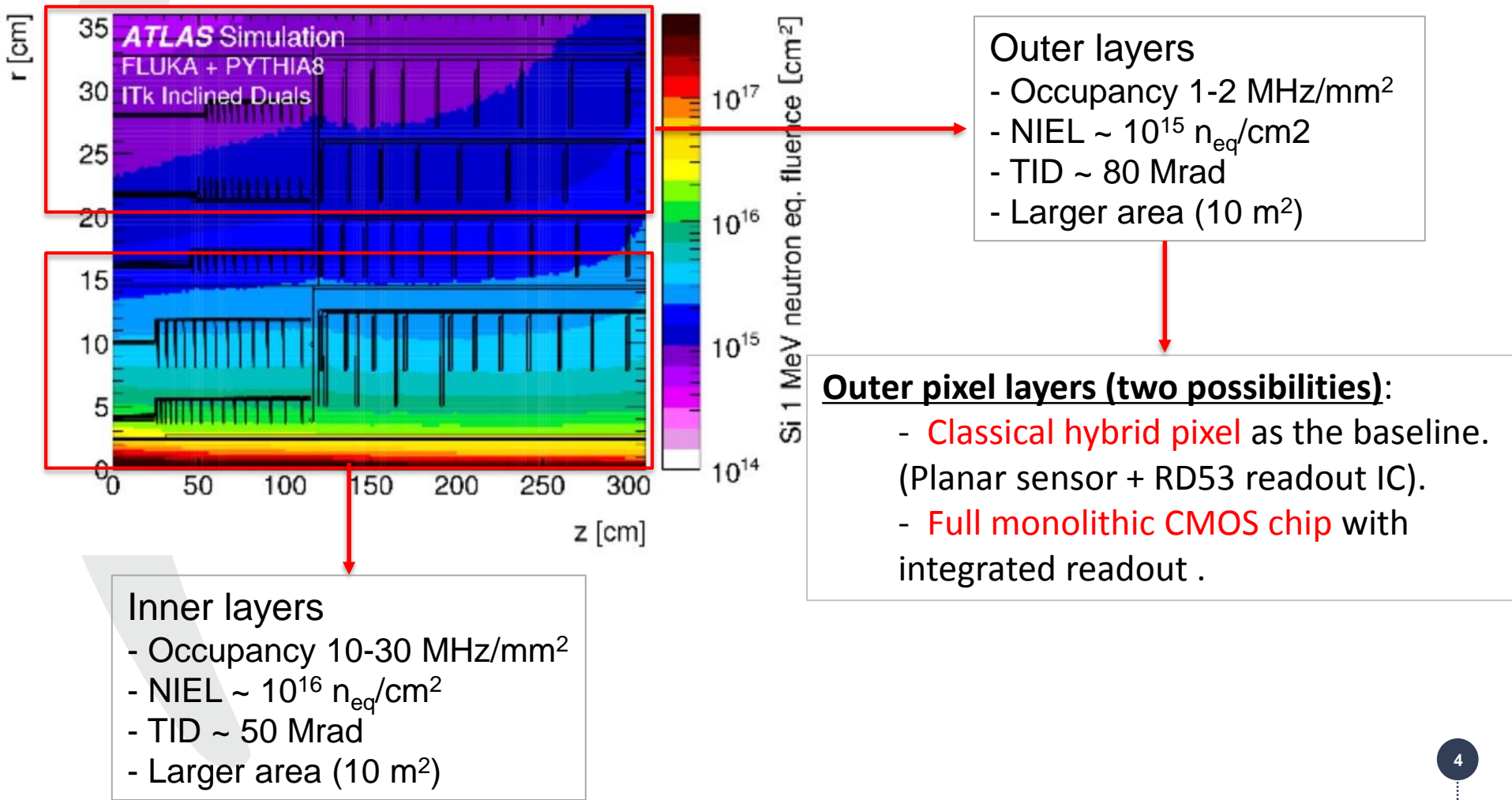
LHC / HL-LHC Plan



- The High Luminosity Large Hadron Collider (HL-LHC) is foreseen to switch on by 2026 with a center of mass energy of 14 TeV and a peak instantaneous luminosity of $7.5 \times 10^{34} \text{ cm}^{-2}\text{s}^{-1}$, **five times higher than at present**.
- The increased luminosity will result in **\sim ten times higher radiation levels and ten times higher data rates**.

ATLAS ITk upgrade for HL-LHC

- To match the requirements in terms of radiation hardness, readout speed and granularity at the HL-LHC, the replacement of the present Inner Tracker (ITk) is needed.

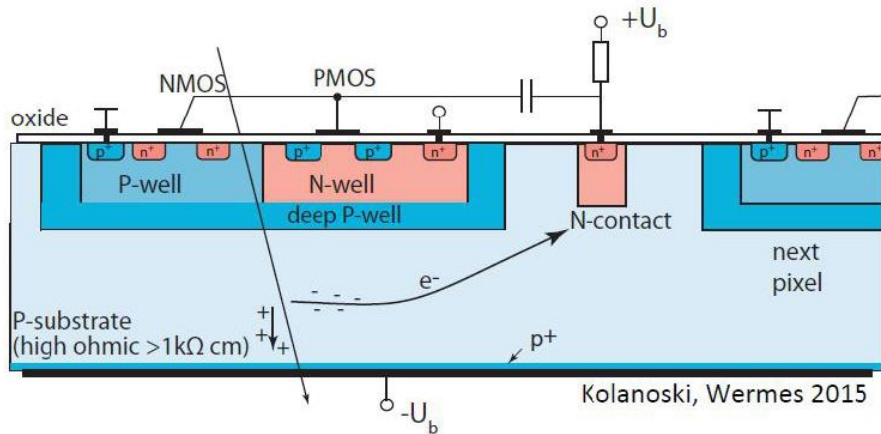


Monolithic CMOS Sensor

- **Commercial** process (mass production technology).
- No hybridization (**reduced material budget and costs, easier procurement**).
- **Considerable depleted regions** in high resistive substrates, **fast charge collection by drift**.

Two design approaches

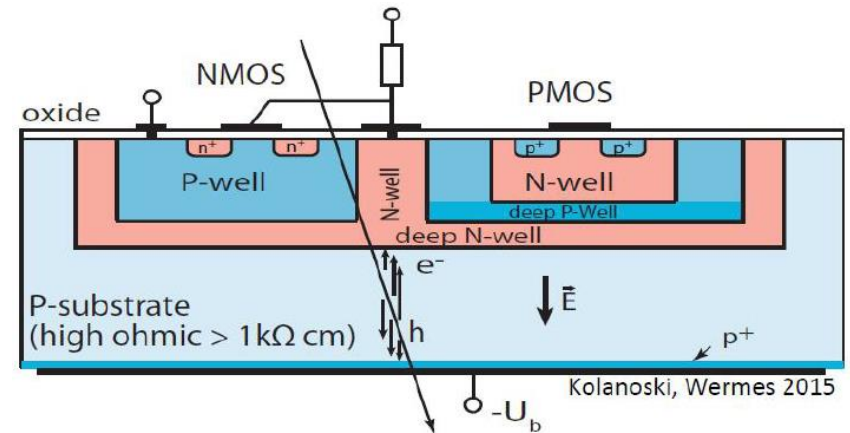
“Small Collection Diode”



PROS: Small sensor capacitance → low power consumption

CONS: Long drift distances → Less radiation hard

“Large Collection Diode”



PROS: Short drift distances → radiation tolerant

CONS: Large sensor capacitance → noise & speed (power) penalties

$$ENC_{thermal}^2 \propto \frac{4 kT}{3 g_m} \frac{C_d^2}{\tau} \quad \tau CSA \propto \frac{1}{g_m} \frac{C_d}{C_f}$$

LFoundry technology

LF technology development line

The process:

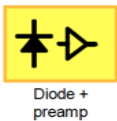
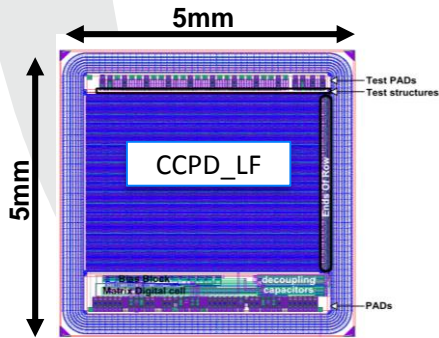
- DeepNW/DeepPW 150nm LF process
- 7 metal layers
- High resistivity (> 2kΩ.cm)

Characterization results (today !)

2014~2015
Small size demonstrator

CCPD LF:

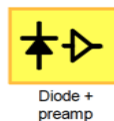
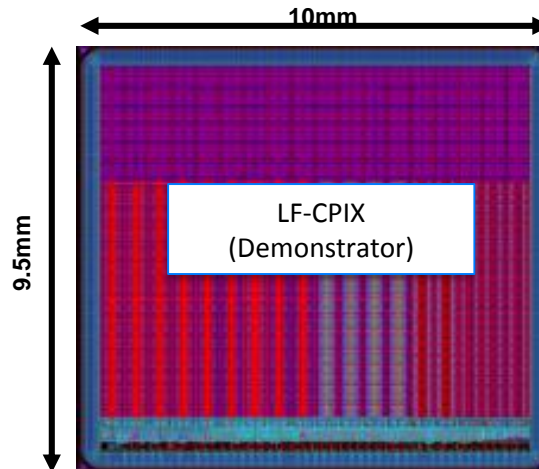
33 × 125µm² pix ; 6pix → 2 FEI4 pix
5 × 5 mm² IC, **bondable to FE-I4**
Bonn / CPPM / KIT



2016~2017
Large size demonstrator

LF-CPIX:

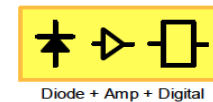
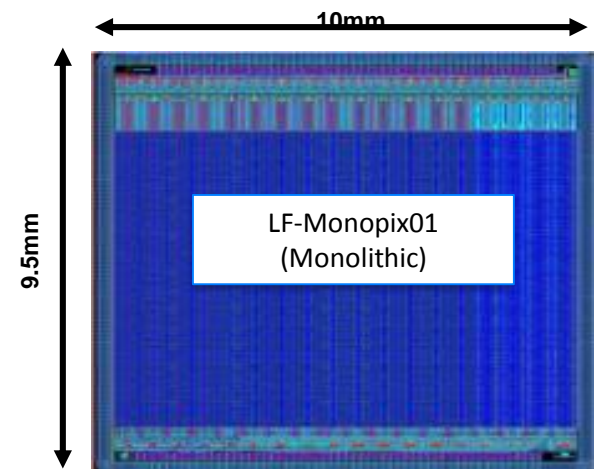
50 × 250µm² pix ; diff. pix flavors
10 × 10 mm²; 2 versions -Guard-Ring-
Bonn / CPPM / IRFU



2017~Present
Large Monolithic demonstrator

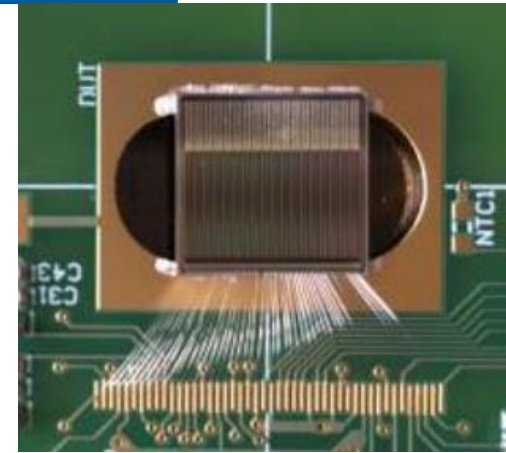
LF-Monopix1:

50 × 250µm² pix
10 × 10 mm² IC
1st full monolithic demonstrator!
Bonn / CPPM / IRFU

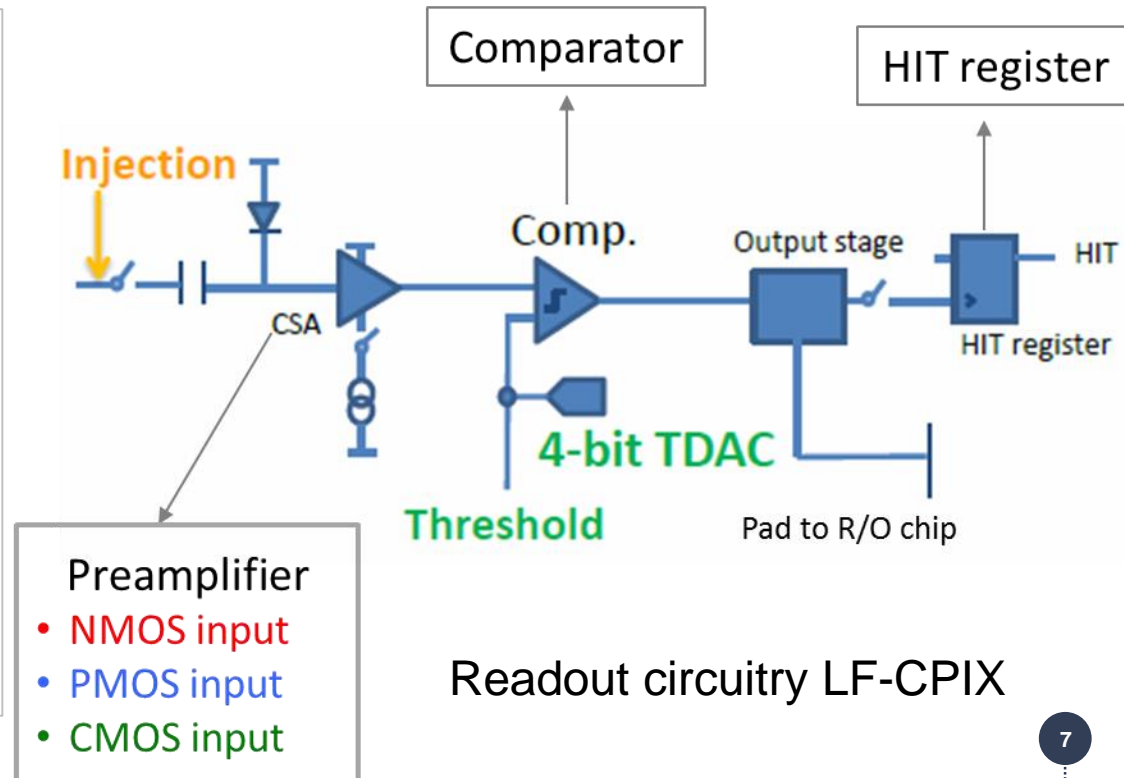


LF-CPIX pixel and matrix architecture

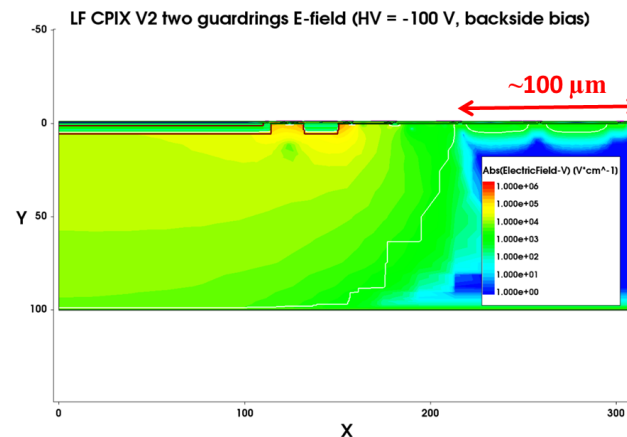
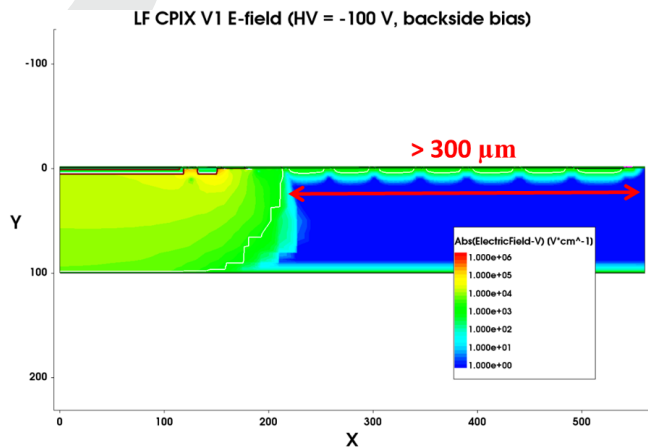
- LF-CPIX:
 - Testing of **sensor diode collection** part.
 - Testing of **analog part** of pixels.



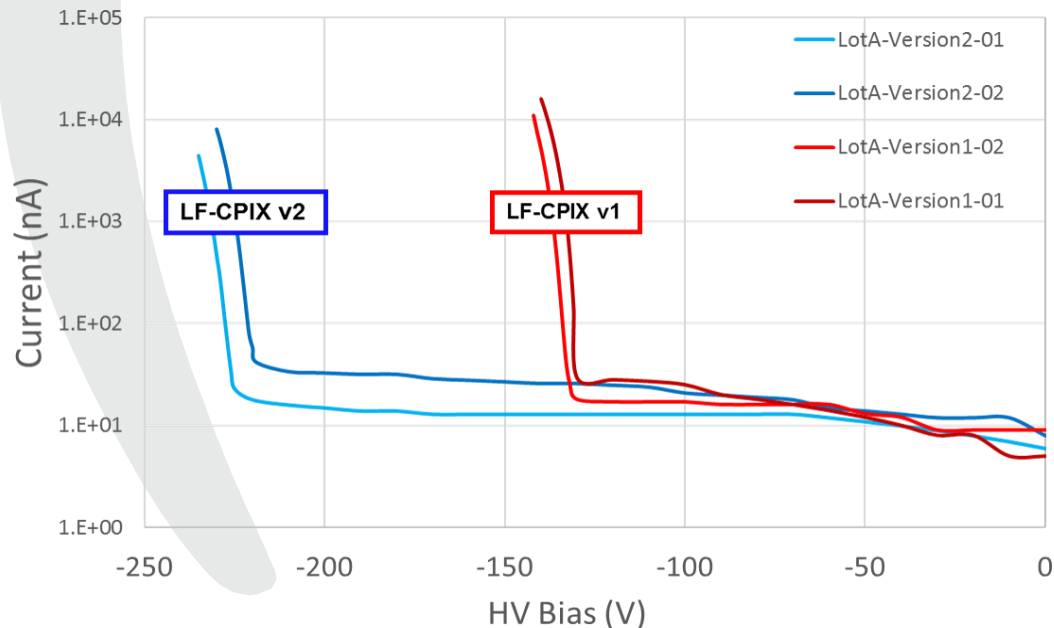
- Process: LFoundry 150 nm CMOS process.
- Wafer resistivity: $>2\text{k}\Omega\text{ cm}$.
- **Pixel size: $250\ \mu\text{m} \times 50\ \mu\text{m}$**
(can be bump bonded to FE-I4 readout chip).
- Matrix: **23×106** .
- Flavor: **3 types of CSA**



Improved guarding-ring strategy for LF-CPIX



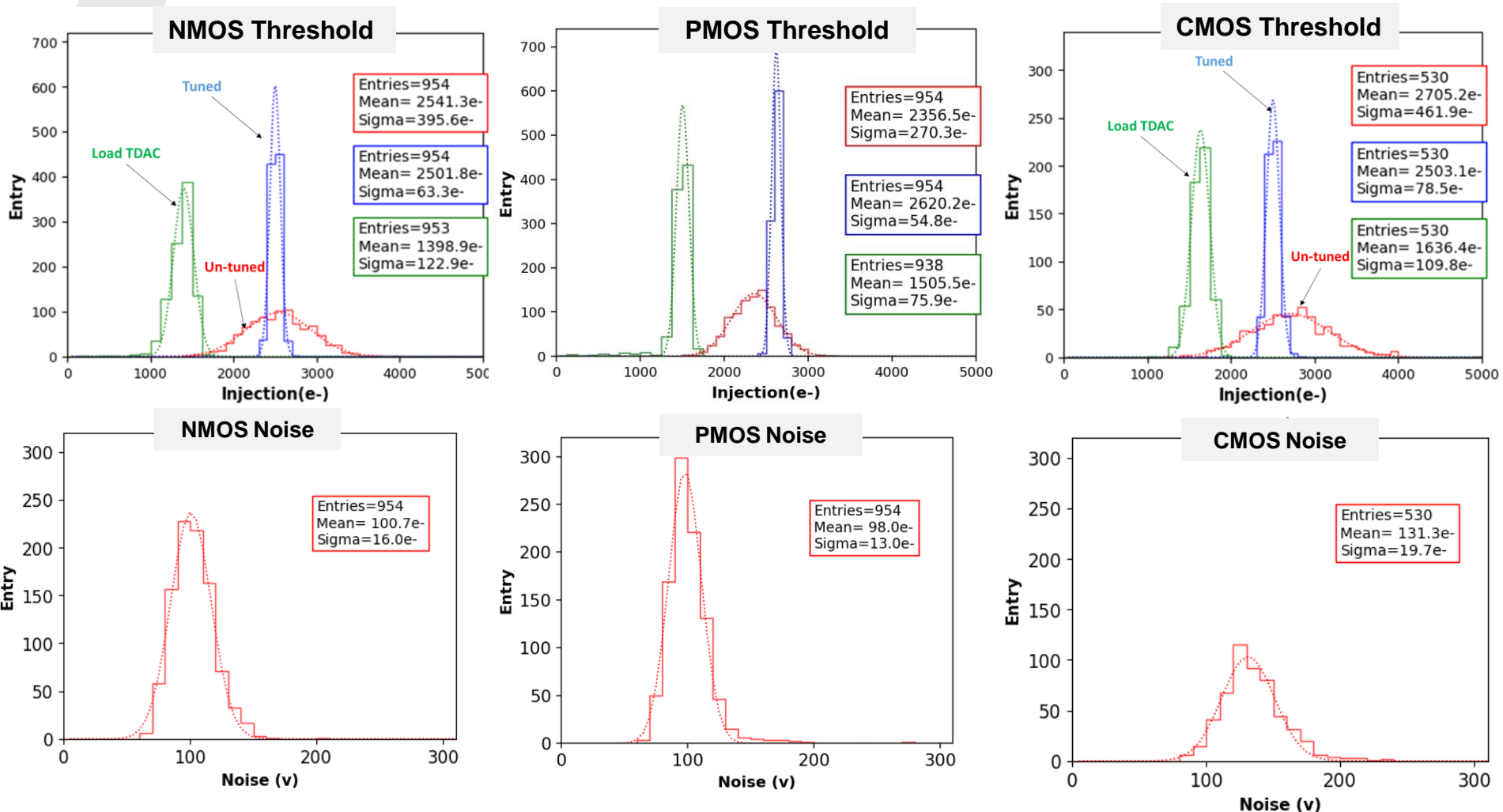
LF-CPIX (V1) $\xrightarrow{\text{guard-ring numbers reducing, guard-ring gap reducing}}$ LF-CPIX (V2)



- Breakdown voltage of V2 is higher than V1, agree with the TCAD simulations!
- The high BV achieved \rightarrow enhanced radiation hardness.

LF-CPIX: Laboratory results before irradiation

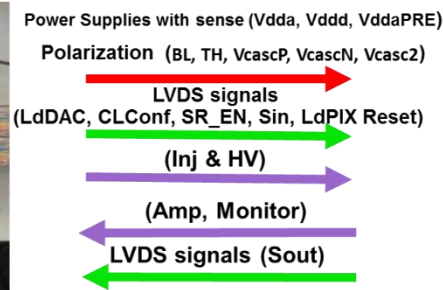
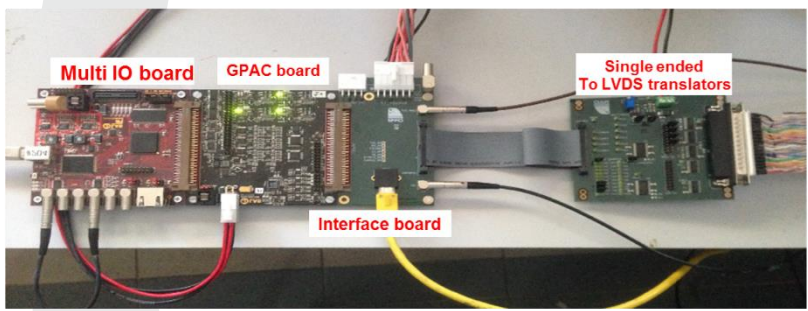
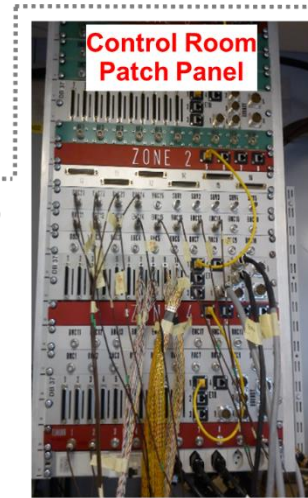
- All 3 flavors are working well and the **threshold can be tuned**, the threshold mean value less than 1500e- can be achieved.
- Typical **noise** mean value less than 130e-.



Setup under proton beam @ CERN PS

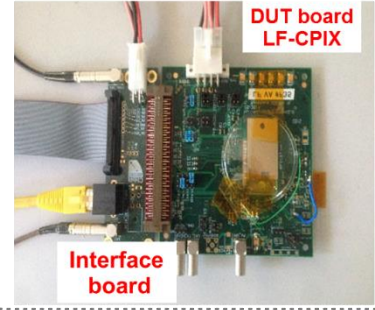
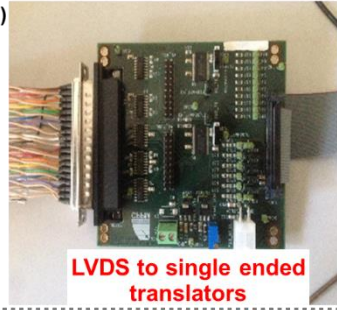
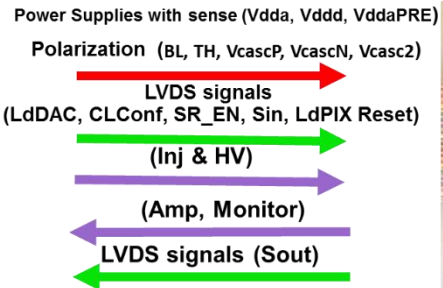
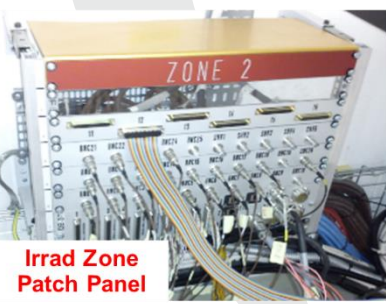
- Aug → Sep 2017 :
- 24 GeV protons irradi.
- ~150 MRad reached (roughly 2 times the dose expected for the ITk 4th layer).
- Fluence: $2.6 \times 10^{15} \text{ n}_{\text{eq}}/\text{cm}^2$.

Setup in Control Room



Setup in Irrad Zone2

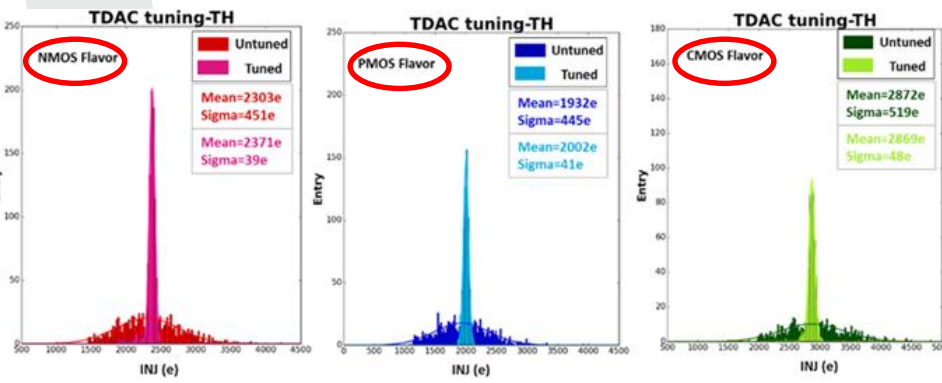
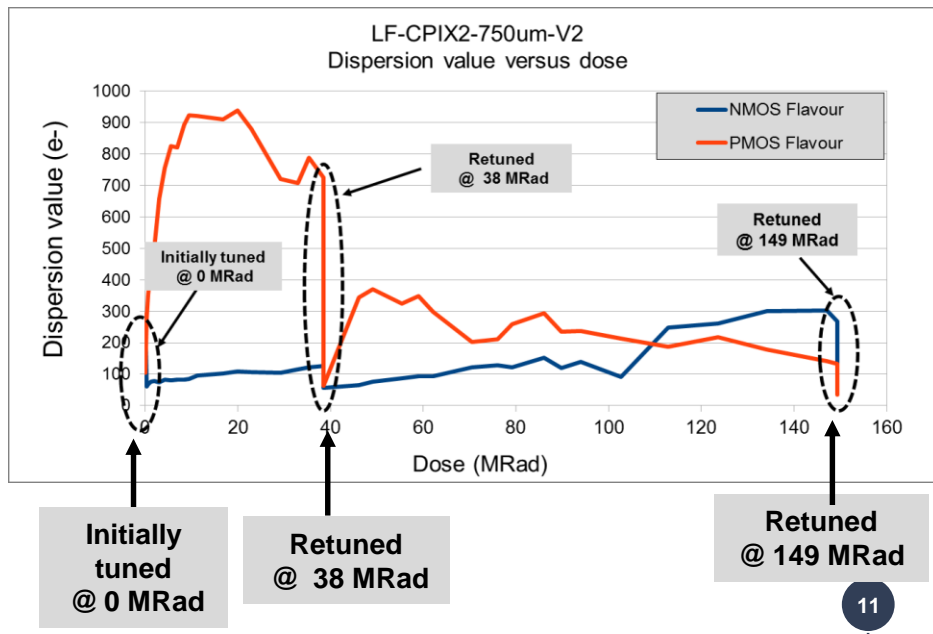
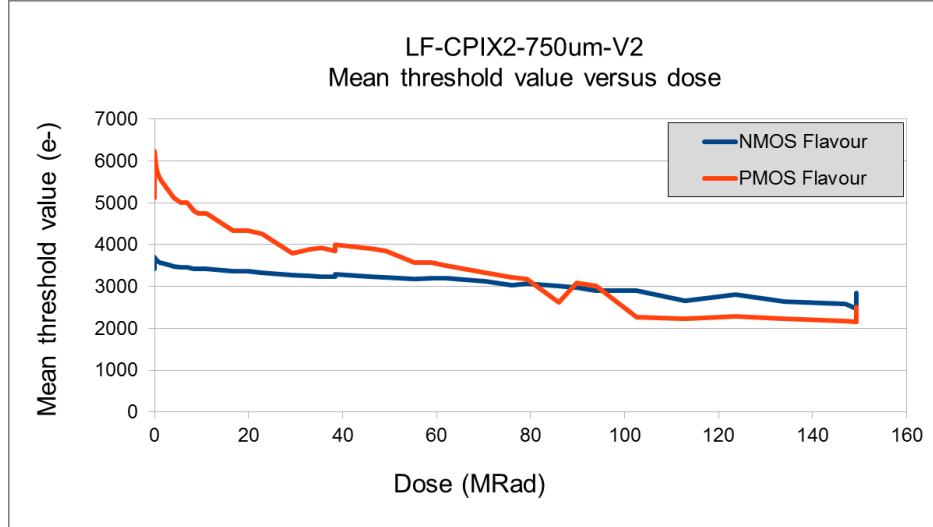
distance of 20m



LF-CPIX testing after irradiation

PS irradiation → 150 MRad

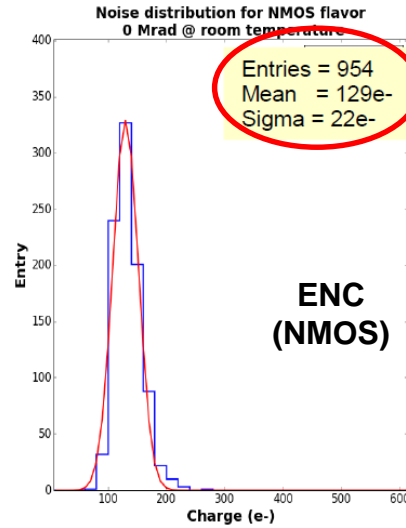
- The threshold mean value for both NMOS and PMOS flavors are 2000e- after proton beam irradiation up to 150MRad.
- The threshold dispersion for the 3 flavors can be tuned to less than 50e- after proton beam irradiation up to 150MRad.



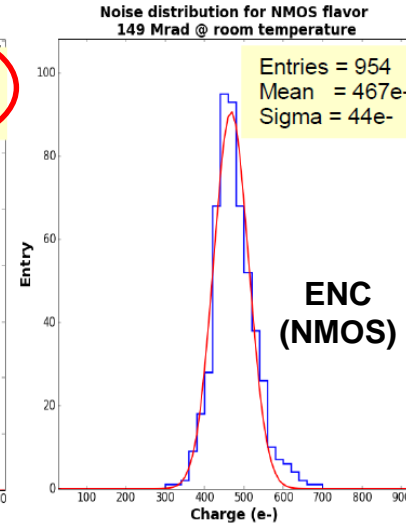
Threshold scan and tuning after radiation

LF-CPIX: Noise after 150 Mrad proton beam irradiation

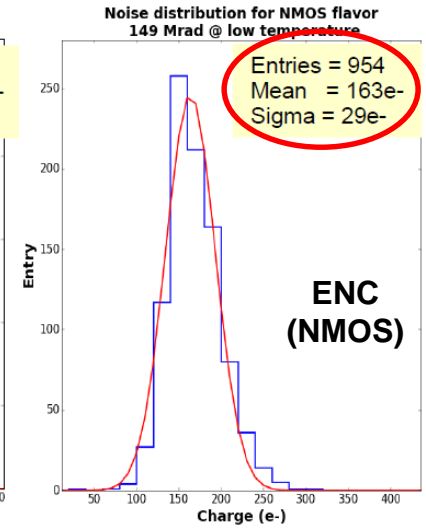
PS irradiation → 150 MRad



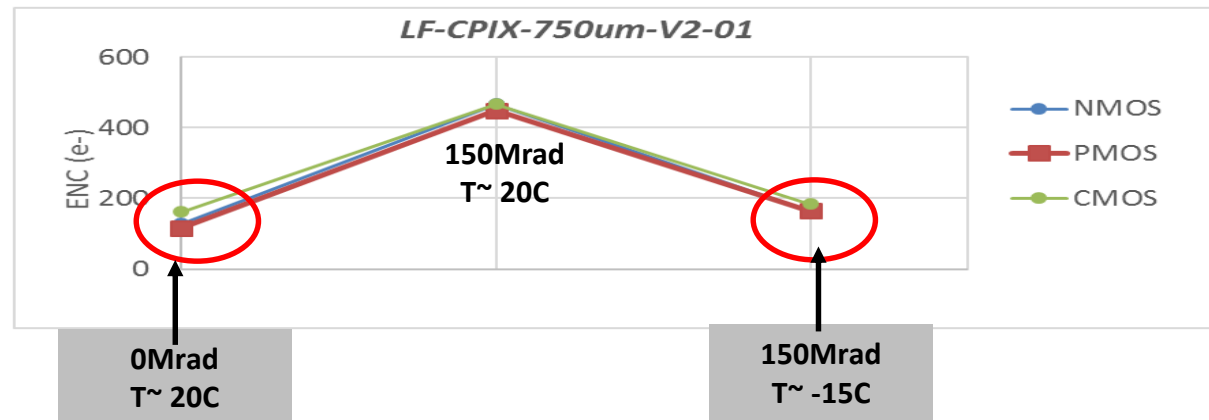
Pre-rad T~ 20C



150 Mrad T~ 20C



150 Mrad T~ -15C

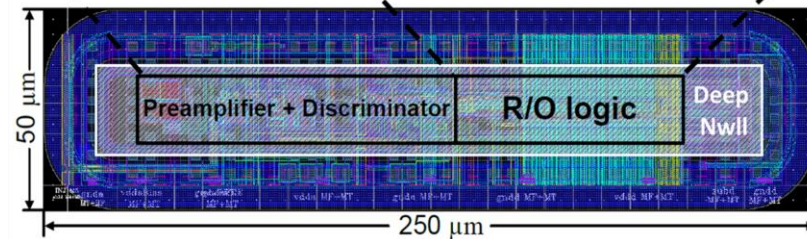
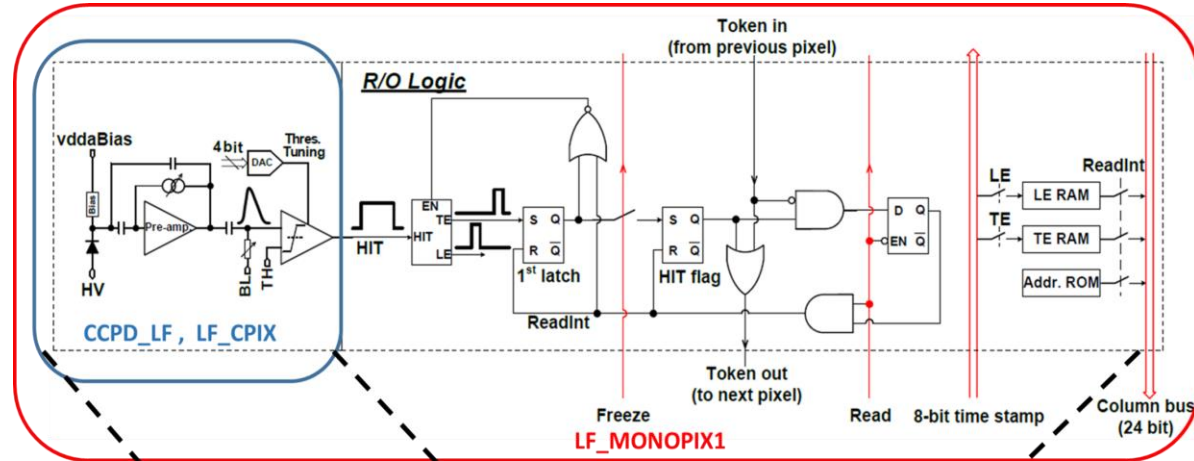


- The noise mean values for all flavors are **less than 200e-** at low temperature after proton beam irradiation up to 150Mrad.

LF-Monopix1: Pixel design



Flavor No	1	2	3	4	5	6	7	8	9
R/O logic	Out		In-Pixel						
Amplifier	CMOS							NMOS	
Discriminator	V2	V1	V2	V1	V2	V1	V2	V1	
Discriminator Domain	Dig		A+D		Dig		A+D		
Token	CMOS			Current Steering					
Source Follower	P	N							

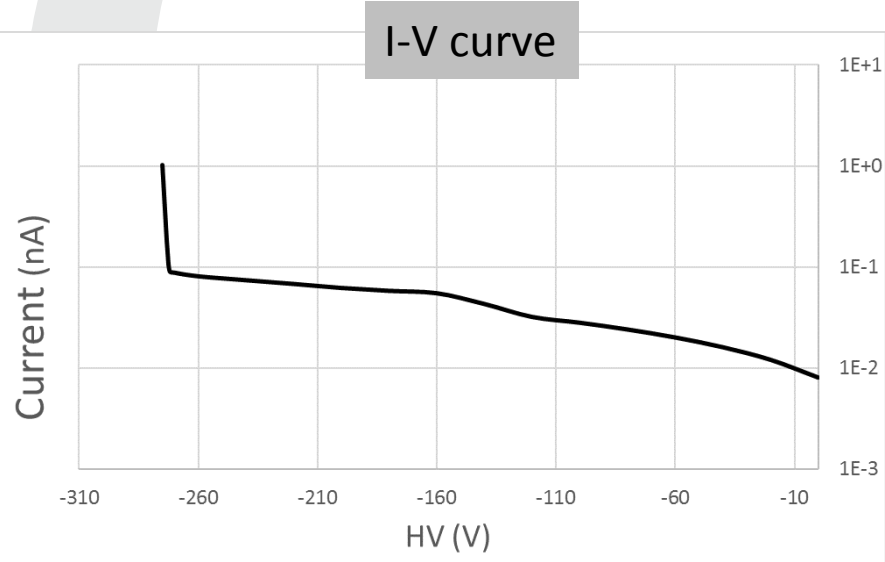


The schematic of LF-MONOPIX1 in-pixel electronics

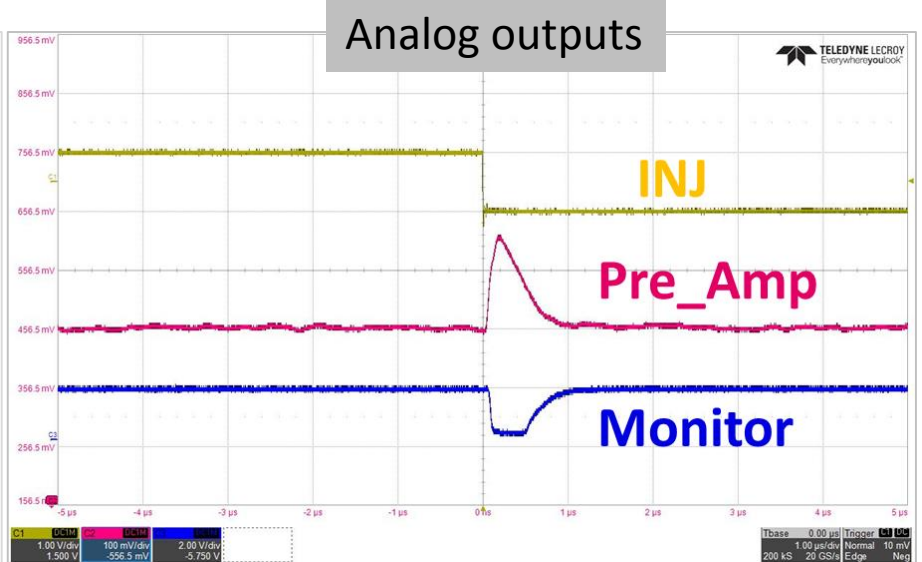
- 150nm CMOS process, LFoundry (Resistivity >2kΩ.cm).
- **Similar diode and analog** front end circuitry design as in LF-CPIX.
- 129 x 36 pixel array (9 sub matrices with different pre-amplifiers, discriminators, R/O concepts ...).
- **Column-drain R/O logic (FE-I3 like).**
- 40 MHz (up to 160MHz by design) LVDS serial output.

LF-Monopix1: Laboratory results before irradiation

- The breakdown voltage is around -280V at room temperature, which is an improved value with respect to previous prototype in this technology and matches simulation results.
- Both the preamplifier and discriminator have good response with external test injection



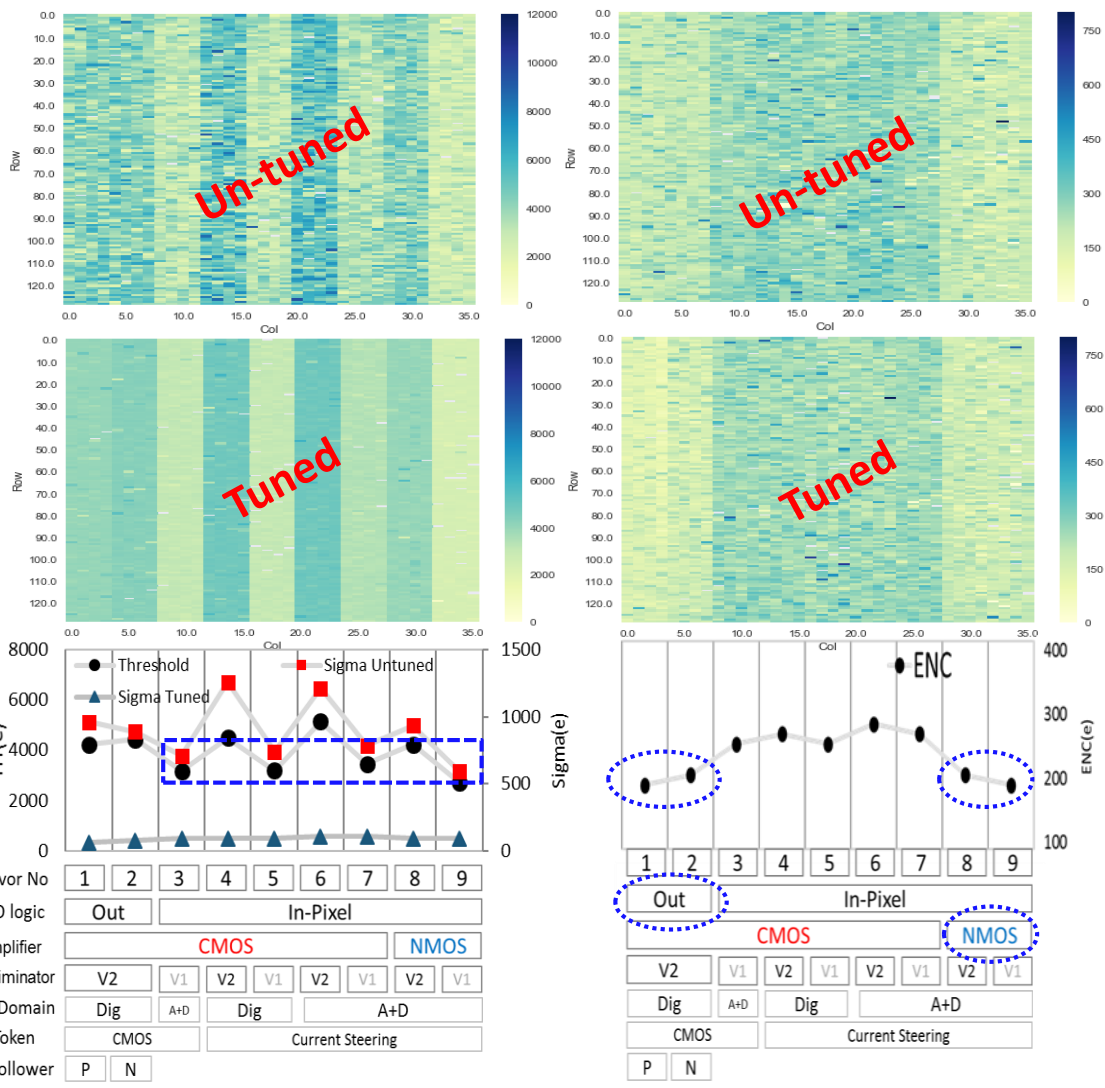
Breakdown ~ -280 V



Responses of the preamplifier and discriminator

LF-Monopix1: Laboratory results before irradiation

- All the flavors of pixels with fully integrated read-out logic can be tuned with a dispersion within $110e^- \sim 148e^-$ depending on flavors. The noise value for different flavors falls between $190 e^-$ and $280 e^-$.
- V1 discriminator shows better performance on dispersion;
- the NMOS input transistor preamplifiers show lower noise than CMOS flavors.



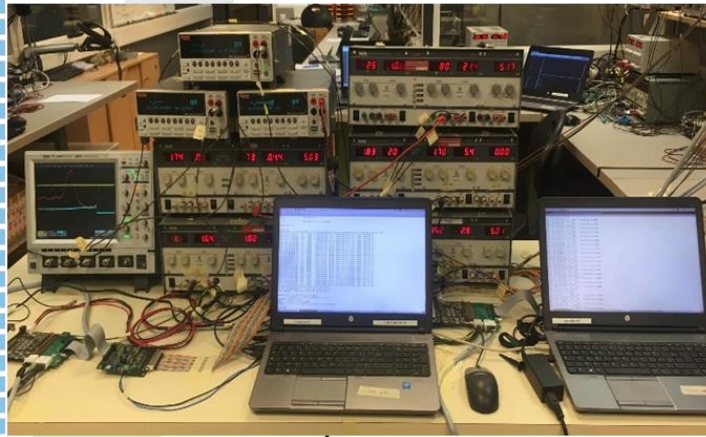
Threshold mapping

Noise mapping

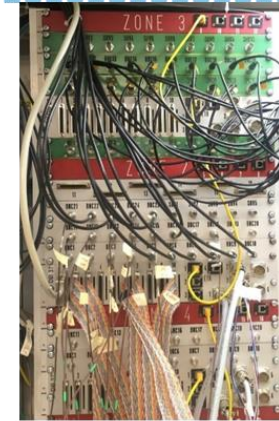
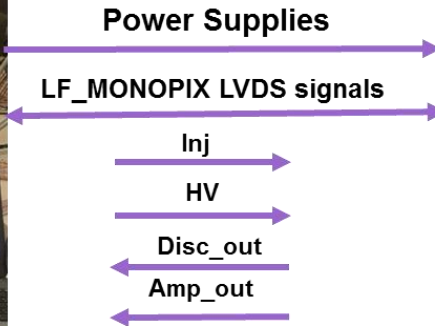
LF-Monopix1: Setup under proton beam @ CERN PS

- Oct → Nov 2018 :
- 24 GeV protons irradi

Setup in Control Room



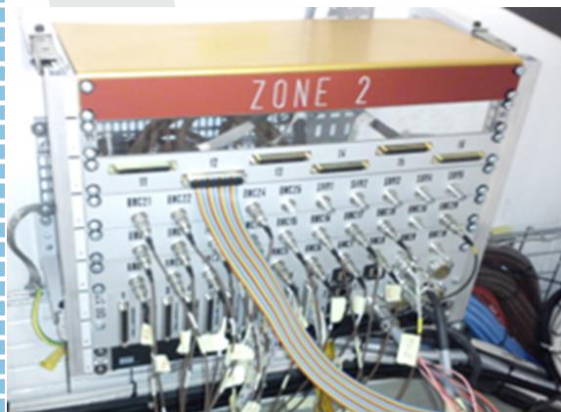
Control Room Setup



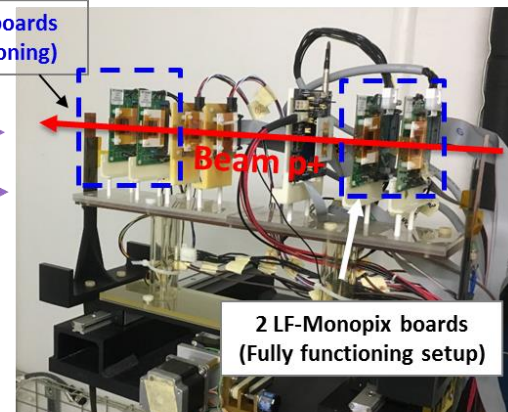
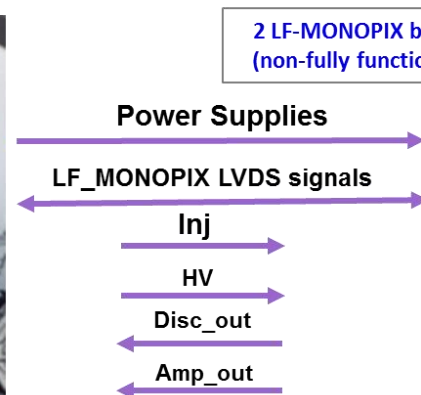
Control room Patch panel

Setup in Irrad Zone2

distance of 20m



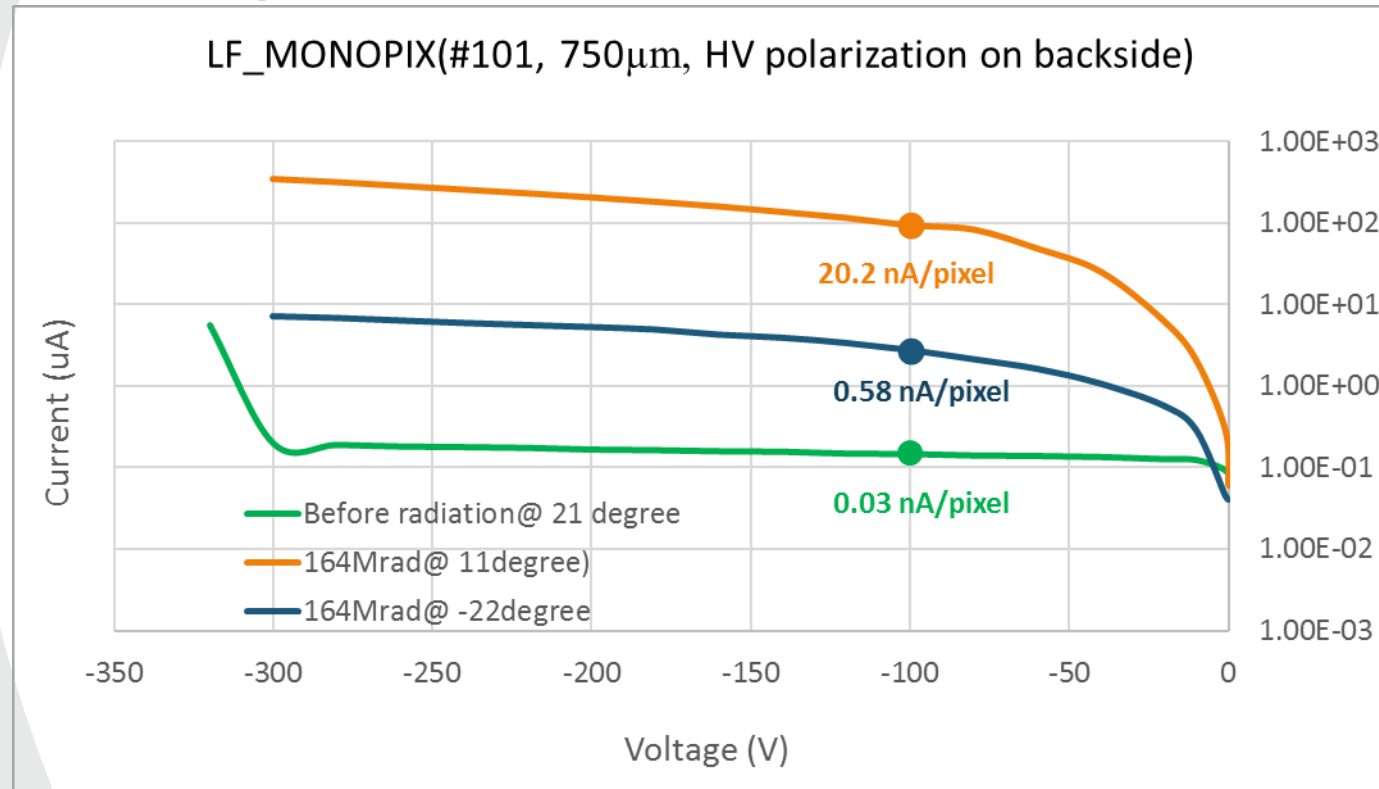
IRRAD Zone Patch panel



IRRAD Zone table

Leakage Current: Radiation under PS@CERN

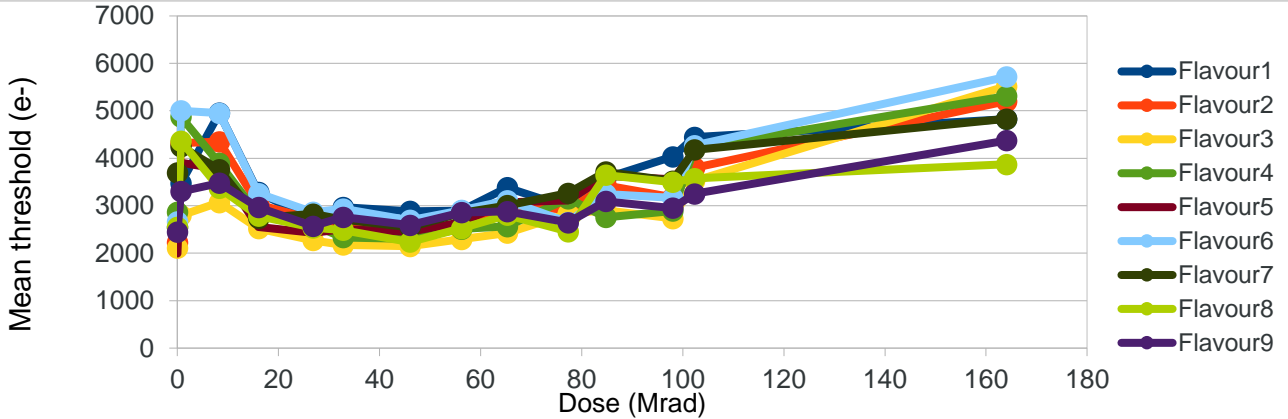
- Oct → Nov 2018 :
- 24 GeV protons irradiad
- TID~164 MRad reached (roughly 2 times the dose expected for the 4th layer)
- $NIEL=2.7 \times 10^{15} n_{eq} \cdot cm^{-2}$



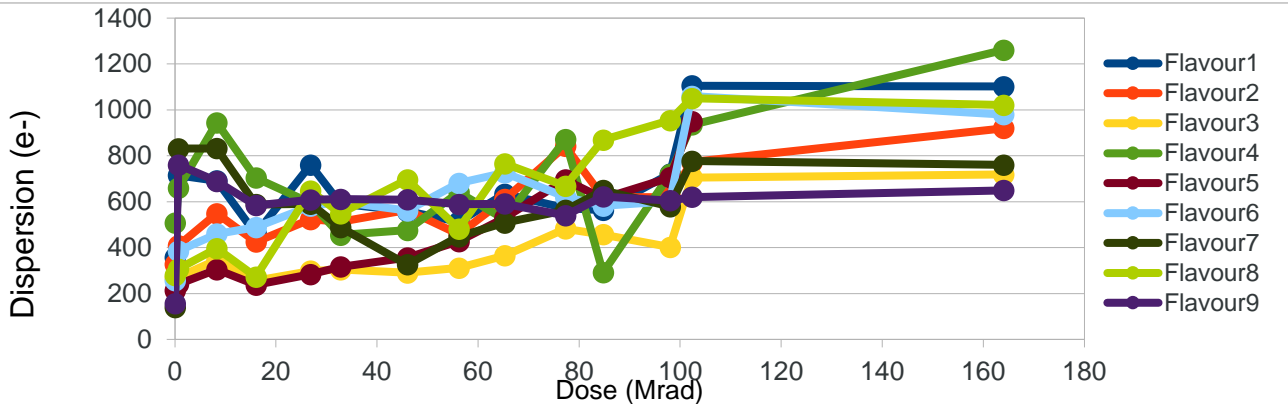
The leakage current increases after irradiations, when the sensor was cooled down to $-22^{\circ}C$ and the per-pixel leakage appears to be less than 0.58 nA, well below the HL-LHC design requirement (10 nA/pixel).

Mean th, dispersion and noise VS Dose (temp=21° C)

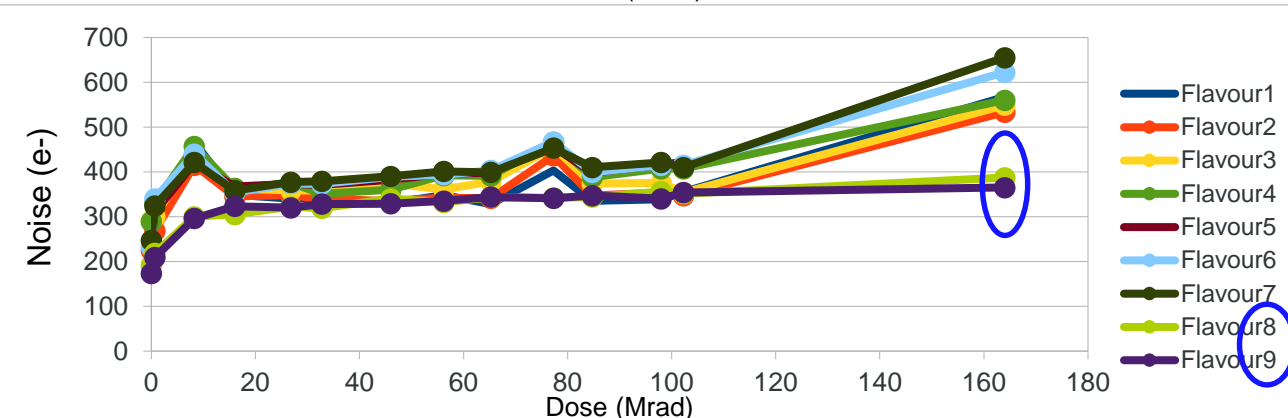
LF_MONOPIX #101 (750um)



Mean threshold versus dose
(Load the tuned TDAC
One column each flavor)



Dispersion versus dose
(Load the tuned TDAC
One column each flavor)



Noise versus dose
(Load the tuned TDAC
One column each flavor)

LF_MONOPIX1: threshold tuning (TID=164Mrad)

- Tested at the end of radiation campaign (Total dose=164Mrad)
- **Flavor9: NMOS CSA + V1 Disc**

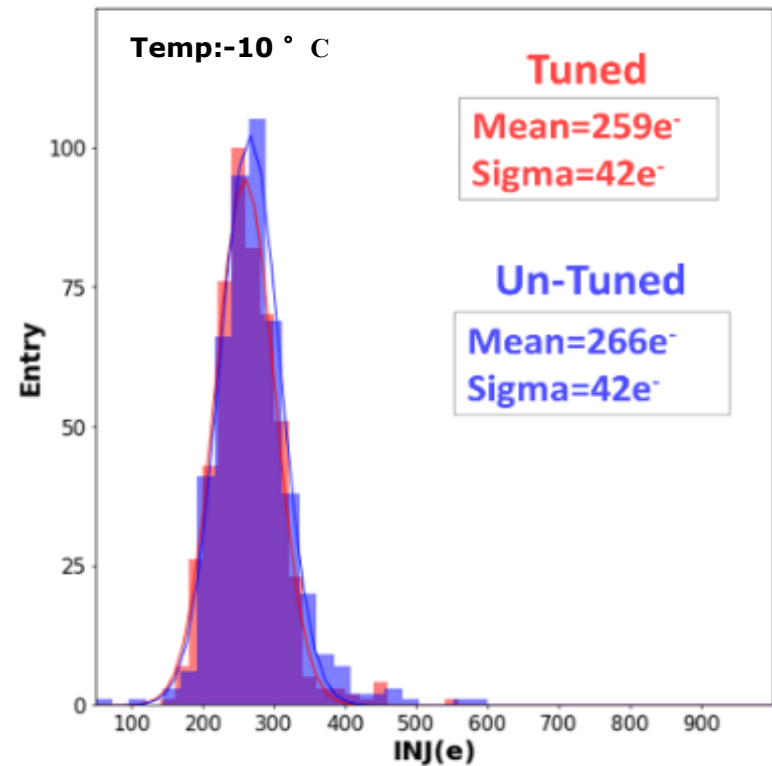
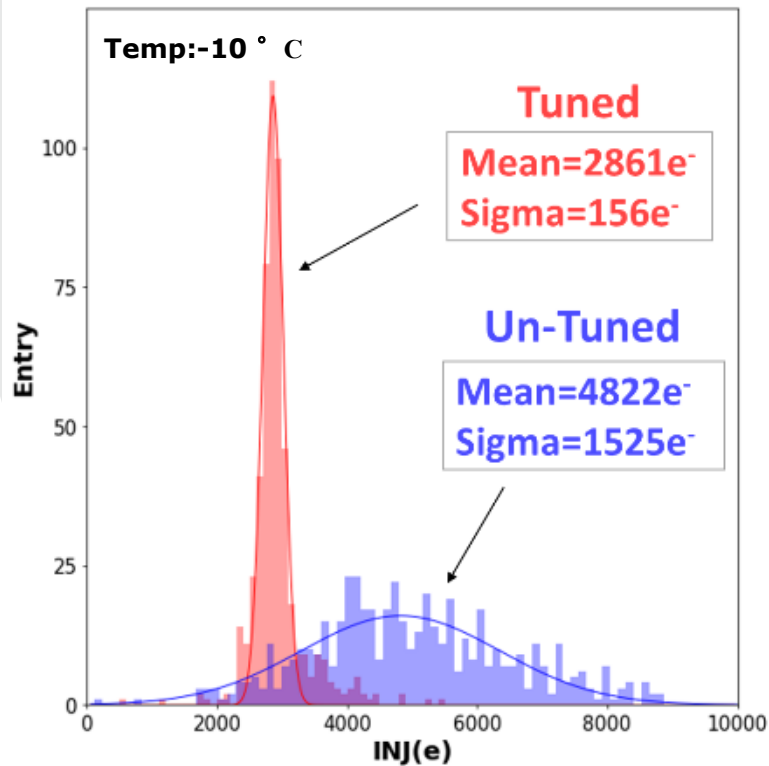
1. Simple threshold scan with global TH

Un-tune
Pixel masked (0.0%)

2. TDAC tuning with same global TH

3. Load the TDAC values with lower global TH

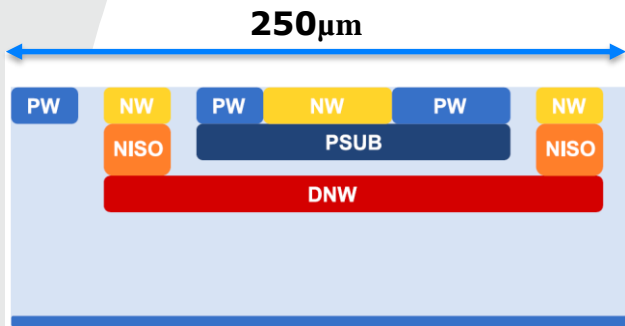
Load TDAC
Pixel masked (1.9%)



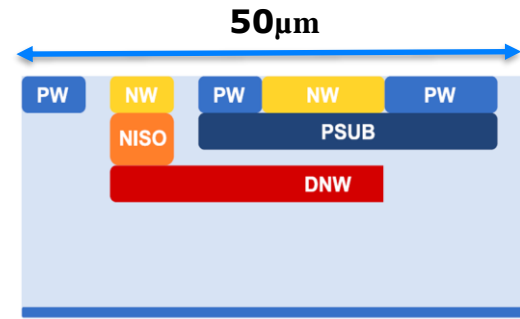
Small pixel approach for LF-MONOX2

Motivation :

- Increase the granularity → Better track parameter resolution, avoid in-pixel pileup at high particle rates.
- Decrease the sensor capacitance → Resulting in low noise.

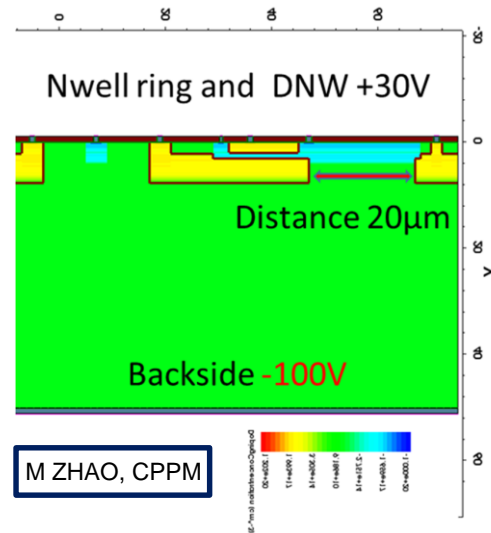


Current Pixel cross-section (250µm × 50µm)

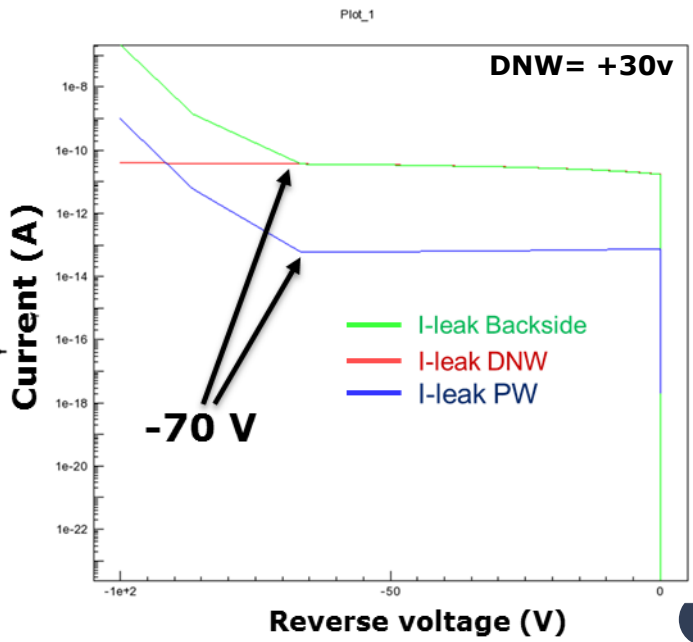


reduce the size of the pixel (50µm × 50µm)

- When the voltage of top Dnwell and Nwell ring is 30V, the BreakDown Voltage is -70V from the substrate, and the current is 50fA from PW and 80pA from DNW.
- The total Voltage potential at **100 V** is achieved.



M ZHAO, CPPM



- Promising results of **LF-CPIX** were shown in terms of:
 - **Good breakdown voltage** characteristics (BV below -200V).
 - **Radiation hardness** of the technology:
 - Tuning of all the 3 flavors possible (threshold dispersion < 50e).
 - **Limited noise increase after 150 Mrad** (noise < 200e).
- **LF-Monopix1**: fully functional demonstrator chip with column drain readout.
 - **Good breakdown voltage** characteristics (BV below -28 0V).
 - **Limited threshold dispersion** (can be tuned within 110e~148e depending on flavor).
 - **ENC** for different flavors is between 190e- to 280 e-.
 - **Good irradiation** performances:
 - TID=164 MRad and NIEL= $2.7 \times 10^{15} \text{ n}_{\text{eq}} \cdot \text{cm}^{-2}$ reached
 - **Limited leakage current increase after 164 MRad.**
 - **Limited ENC increase.**
 - The threshold can be **tuned down to 2861 e- with a dispersion 156 e-.**
- **Next step and Outlook.**
 - Need to understand the radiation effect on different parts of the chip.
 - Need to reduce the pixel size and leakage current (layout optimization).
 - Based on the results of the LF-MONOPIX1, find best strategy for the next demonstrator.

The collaboration works on an improved full size LF_MONOPIX2 and small pixel ICs that could be used in ATLAS ITk outer layer or in other contexts. → target: end of 2019

My PhD activities

Simdet 2016



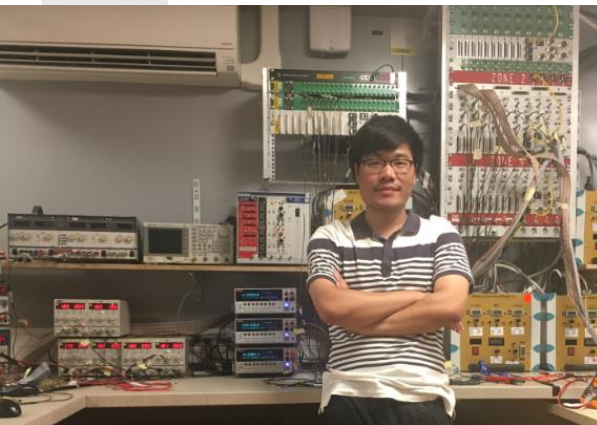
Annual meeting 2017



Vienna Business School



Secondment at CERN



TWEPP 2018



CV Writing & Job Interview Workshop 2019





Thanks for your
attention !

